INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)	Application Number
485	532 Rec'd PCT/PTC 18 OCT 2000
Applicant(s) Heinrich Meyer et al	09/673760
Filing Date Herewith	Group Art Unit 1763

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AWD	AA	3,294,059	12/27/66	Barnes et al	118	49.5	
AWD	AB	4,717,587	1/5/88	Suhr et al	427	039	
AWD	AC	4,990,363	2/5/91	Suhr et al	427	040	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	Translation NO
AWD	AL	35 10 982 A1	9/25/86	Germany				
	AM	35 12 196 A1	10/16/86	Germany				
	AN	37 44 062 A1	7/13/89	Germany				
	AO	38 06 587 A1	9/7/89	Germany				
AWD	AP	44 38 791 A1	4/25/96	Germany				

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

AWD	AR	"Thin Palladium Films Prepared by Metal-Organic Plasma-Enhanced Chemical Vapor Deposition", Thin Solid Films, Band 157 (1988), p. 81-86.

EXAMINER	DATE CONSIDERED
Alla Olan	6-19-03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.